

EMPIRICAL PSEUDOPOTENTIAL METHOD FOR MODERN
ELECTRON SIMULATION

by

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Empirical Pseudopotential Method for Modern Electron Simulation

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ABSTRACT

The topic of this thesis is to develop a framework for finding critical values that can be used in simulating modern semiconductor device structures. Many current simulation tools use effective mass approximations to model the propagation of electrons through a device. Because modern devices take advantage of different materials, geometries and sizes, a band structure calculation becomes necessary for representing effects such as strained materials and hot carriers. While highly accurate, calculation-intense methods exist, a band structure may need to be recalculated on-the-fly creating the need for a fast, simple algorithm that can be tailored for the situation at hand.

Fortunately, there is a very well established method for calculating band structure based on physical properties of the material. Historically, these properties were measured, but modern techniques involve using algorithms to converge to the proper values. This allows the simulation of devices with interesting properties while maintaining relatively simple models.

The form and content of this abstract are approved. I recommend its publication.

Approved: Hamid Z. Fardi

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1. Introduction

Knowing the band structure of a material is important for relating its optical and electronic properties. As new and exotic materials are studied, there is a greater need for energy band calculations. Special physical properties can be studied without building devices. Band structure calculations can be used to engineer custom band structures to tailor optical or electrical devices.

Though calculation of band structure is valuable in its own right, in this paper the focus will be on its importance with regard to semiconductor simulation. In order to understand, design and model new devices it is imperative to know the limitations and applications of different methods. For calculating band structure there are two basic approaches: ab initio and empirical methods. Ab initio, or “from the beginning” methods involve calculation of band structure by use of first-principles without using measured data. Empirical methods take advantage of experimental data to give more accurate band structure representation. Generally, ab initio methods are calculation intensive but give better insight on how the structure arrives. Both methods have their place in calculating and engineering transport properties in semiconductor devices.

Examples of ab initio methods are the Hartree-Fock[44] and Density Functional Theory (DFT)[39]. Hartree-Fock method is Based on Linear Combination of Atomic Orbitals (LCAO) and uses the muffin-tin atom orbital as the method. Several other methods based on LCAO can be employed. The DFT method projects the system of interacting particles into a system of non-interacting particles. Ab initio methods are useful for looking into properties of new materials, such as the currently popular graphene material. QuantumWise[1] is an example of a program that uses ab initio methods for simulations. It will be shown that empirical methods can also be used for exciting materials without being as bulky as first principle based methods.

Some common empirical methods are k·p and EPM. k·p takes advantage of effective mass theory in its calculations. EPM is the topic of this paper and its applications and limits will be

discussed further in the following sections.

1.1 Device Simulation

Semiconductor device simulation can be grouped into three basic categories: Classical, Semi-classical and Quantum. The manufacturing process for semiconductor devices requires that logic and electrical performances be simulated long before they go into production. Most simulators use classical techniques with parameters belted on to account for special situations. The classical approach is still used because it enables complex devices to be simulated quickly. Semi-classical approaches have evolved as a way of engineering, studying and even revealing parameters for classical simulations in new materials. In all of these methods the Poisson equation is used to describe the electrostatic part of the system,

$$\epsilon \delta \varphi = q(n - p - C) \quad (1.1)$$

where the space charge density, $\rho = q(n - p - C)$ consists of the charge of an electron q multiplied by the difference of the number of electron (n), hole (p) carriers and the concentration of charges C . Each method takes “moments” of the Boltzmann equation and simplifies them to self-consistently solve the system. The Drift-Diffusion model is the simplest and it uses current continuity to solve both static devices and slow changes in current. The model focuses on two mechanisms, namely drift of charge carriers due to an external electric field and diffusion caused by a gradient in charge carrier concentration.

The major simplification of Drift-Diffusion is that it assumes that lattice temperature and charge carrier temperature is equal. However, this is almost never the case. The Hydrodynamic model is somewhat more complex but accounts for the constant change in temperature inherent in all devices.

Semi-classical simulations involve calculating the density of states of the system (and therefore the band structure) and applying it the moments of the Boltzmann Transport Equation. For whichever assumptions and simplifications that are made the equations will be solve self consistently

with the Poisson equation.

Finally, The Wigner function approach removes all ballistic, classical properties of the system by replacing the Poisson equation with the Wigner-Boltzmann equation.

1.2 A Breif History of Pseudopotentials and Band Structure Calculation

Since core electrons in the inner shells of atoms are strongly bound, they do not play a significant part in the electronic and optical properties. The Philips Kleinman cancellation theorem[37] creates a smooth wave function to represent the core energies and potentials by taking advantage of crystal symmetry, and allows for simple calculation of wave energies. The previous method proposed by Herring in 1940 (and still of importance when core electrons must be taken into account) involved orthogonalization of each plane wave creating a linear combination of core orbitals[28]. This method was successful in improving accuracy for specific applications, but was admittedly laborious. Spherical symmetry of the core was lost due to signalizing a single plane wave to the core functions, and this limited its use to metallic structures. In 1953, Slater effectively solved the symmetry issue by using Bloch waves to represent the periodicity of a crystal. The final step to what we call EPM was to smooth the contribution of the core atoms by using an effective potential. The secondary benefit of doing this is that molecules can also be modeled in the system. [37] discusses the possibility of modifying the repulsive potential to reproduce the free-atom term values. This ironically hints at the powerful adaptability of the model.

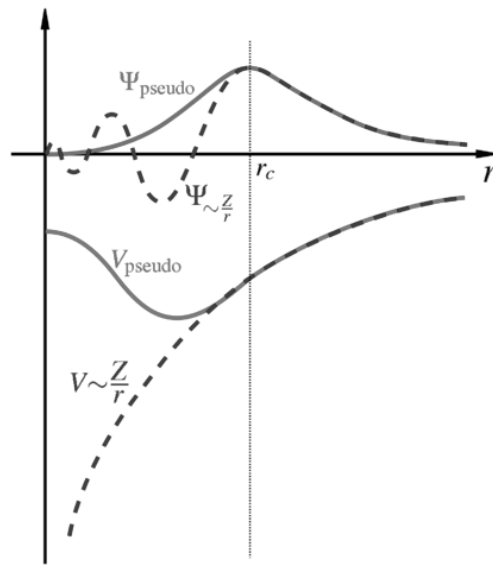


Figure 1.1: A graphical representation of pseudopotential simplification

2. Empirical Pseudopotential Method

2.1 EPM Proof

Herring's Orthogonalized Plane Wave (OPW) method is the starting point for EPM. By assuming s or p atomic symmetry Ψ_k is constructed to be orthogonal to the core states,

$$\Psi_k = \varphi_k + \sum_t a_{k,t} \phi_{k,t} \quad (2.1)$$

where $a_{k,t}$ are the orthogal coefficients and $\phi_{k,t}$ are the core wave functions. We seek a solution that gives φ_k as a smooth function. Using the Schrodinger equation,

$$H\Psi_k = E\Psi_k \quad (2.2)$$

and substituting (2.1) into (2.2) we get,

$$H\varphi_k + \sum_t a_{k,t}(E - E_t)\phi_{k,t} = E\varphi_k \quad (2.3)$$

Introducing

$$V_r = \sum_t a_{k,t}(E - E_t)\phi_{k,t}/\varphi_k \quad (2.4)$$

where V_r represents the short-range repulsive potential; we have the desired form to find the “smooth” function,

$$(H + V_r)\varphi_k = E\varphi_k \quad (2.5)$$

By adding the Hamiltonian operator,

$$H = \frac{p^2}{2m} + V_c \quad (2.6)$$

where V_c represents the core potential. Inserting (2.6) into (2.5), we get the eigenvalue problem,

$$(\frac{p^2}{2m} + V_c + V_r)\varphi_k = E\varphi_k \quad (2.7)$$

It can be seen from (2.7) that the core and the short-range potentials can be added together to equal a pseudopotential $V_p = V_c + V_r$, which is known as the Phillips-Kleinman cancellation theorem. The eigenvalue energy of (2.7) is the actual energy of the crystal wave Φ_k . and φ_k can be thought of as the pseudo-wave function.

The actual contributions of each orbital can be added up through LCAO to create V_p , but historically EPM used potentials measured empirically. Modern methods use other known properties to converge to useful pseudopotentials for different applications or materials.

2.2 Method for Band Structure Calculation

Solving the Schrodinger equation is all that is needed to find the band structure of a particular material. Unfortunately, this is a nontrivial exercise. We will focus on discrete points along the Brillouin Zone (BZ). Starting with the Time Independent Schrodinger Equation (TISE),

$$\left[-\frac{\hbar^2}{2m}\nabla^2 + V(\mathbf{r})\right]\Psi(\mathbf{k}, \mathbf{r}) = E(\mathbf{k})\Psi(\mathbf{k}, \mathbf{r}) \quad (2.8)$$

Both the wave function and the potential must be discretized. Since the wave function is periodic, it can be written in Bloch form and as a series,

$$\Psi(\mathbf{k}, \mathbf{r}) = e^{i\mathbf{k}\mathbf{r}} u_{\mathbf{k}}(\mathbf{r}) = e^{i\mathbf{k}\mathbf{r}} \sum_{\mathbf{h}} A_{\mathbf{h}} e^{i\mathbf{K}_{\mathbf{h}}\mathbf{r}} \quad (2.9)$$

where \mathbf{k} is the crystal wave vector, \mathbf{r} is the position and $u_{\mathbf{k}}(\mathbf{r})$ is a periodic function with the same periodicity as the crystal. Similarly the potential is periodic,

$$V(\mathbf{r}) = \sum_{\mathbf{m}} V_{\mathbf{m}} e^{i\mathbf{K}_{\mathbf{m}}\mathbf{r}} \quad (2.10)$$

By substituting (2.9) and (2.10) into (2.8) we arrive at a nearly discrete function,

$$\frac{\hbar^2}{2m} \sum_{\mathbf{h}} |\mathbf{k} + \mathbf{K}_{\mathbf{h}}|^2 A_{\mathbf{h}} e^{i(\mathbf{k} + \mathbf{K}_{\mathbf{h}})\mathbf{r}} + \sum_{\mathbf{m}} \sum_{\mathbf{h}} V_{\mathbf{m}} A_{\mathbf{h}} e^{i(\mathbf{k} + \mathbf{K}_{\mathbf{h}} + \mathbf{K}_{\mathbf{m}})\mathbf{r}} = E(\mathbf{k}) \sum_{\mathbf{h}} A_{\mathbf{h}} e^{i(\mathbf{k} + \mathbf{K}_{\mathbf{h}})\mathbf{r}} \quad (2.11)$$

To take advantage of orthogonality (2.11) is multiplied by $e^{i(\mathbf{k} + \mathbf{K}_{\mathbf{h}})\mathbf{r}}$ and integrated to give,

$$\frac{\hbar^2}{2m} \sum_{\mathbf{h}} |\mathbf{k} + \mathbf{K}_{\mathbf{h}}|^2 A_{\mathbf{h}} \delta_{h,l} + \sum_{\mathbf{m}} \sum_{\mathbf{h}} V_{\mathbf{m}} A_{\mathbf{h}} \delta_{m,l-h} = E(\mathbf{k}) \sum_{\mathbf{h}} A_{\mathbf{h}} \delta_{h,l} \quad (2.12)$$

where $\delta_{h,l}$ are Kronecker delta functions. In other words,

$$\delta_{h,l} = \begin{cases} 1 & \text{if } h = l \\ 0 & \text{if } h \neq l \end{cases} \quad (2.13)$$

This can be simplified further since $h = l$ only happens once for the first term of the left-hand side, h times for the second term and once for the right-hand side,

$$\frac{\hbar^2}{2m} |\mathbf{k} + \mathbf{K}_h|^2 A_h + \sum_h V_h A_h = E(\mathbf{k}) A_h \quad (2.14)$$

(2.14) is an eigenvalue problem. All that is needed to find $E(\mathbf{k})$ is to construct the Hamiltonian and solve for the eigen values,

$$H_{i,j} = \frac{\hbar^2}{2m} |\mathbf{k} + \mathbf{K}_h|^2 \delta_{i,j} + V \quad (2.15)$$

where,

$$V = V_S \cos(K_m \cdot \tau) + iV_A \sin(K_m \cdot \tau) \quad (2.16)$$

and,

$$\tau = a\left(\frac{1}{8}, \frac{1}{8}, \frac{1}{8}\right) \quad (2.17)$$

(2.16) accounts for two atoms per lattice point where the maximum offset is τ . V_S are form factors and are measured experimentally. The actual code starts by creating two tables used during the actual calculation process. The first table contains all of the \mathbf{k} values. The second table is the precalculated bottom half of the Hamiltonian matrix. The eigen solver library[24] only needs the lower half if the matrix is Hermitian. Since these values do not change for different \mathbf{k} , they can be precalculated. Creating these tables reduces the execution time and simplifies the creation of the Hamiltonian matrix in the main execution loop.

Once these tables are created, the main execution loop is started. The diagonals for a given \mathbf{k} are calculated and added to the the template H matrix. After the Hamiltonian is built, the eigen library finds the eigenvalues for a given \mathbf{k} . It should be noted the the number of points used for \mathbf{k} determines the resolution for the Brillouin Zone, while the number of \mathbf{K} points determines the accuracy for the Energies of Eigen Values.

Table 2.1: Form factors of Si, Ge, Sn, GaP and GaAs at 300K from [11]

| | $a(\text{\AA})$ | V_{3S} | V_{8S} | V_{11S} | V_{3A} | V_{4A} | V_{11A} |
|------|-----------------|----------|----------|-----------|----------|----------|-----------|
| Si | 5.43 | -0.21 | 0.04 | 0.08 | 0 | 0 | 0 |
| Ge | 5.56 | -0.23 | 0.01 | 0.06 | 0 | 0 | 0 |
| Sn | 6.49 | -0.20 | 0 | 0.04 | 0 | 0 | 0 |
| GaP | 5.44 | -0.22 | 0.03 | 0.07 | 0.12 | 0.07 | 0.02 |
| GaAs | 5.64 | -0.23 | 0.01 | 0.06 | 0.07 | 0.05 | 0.01 |
| AlSb | 6.13 | -0.21 | 0.02 | 0.06 | 0.06 | 0.04 | 0.02 |
| InP | 5.86 | -0.23 | 0.01 | 0.06 | 0.07 | 0.05 | 0.01 |
| GaSb | 6.12 | -0.22 | 0.00 | 0.05 | 0.06 | 0.05 | 0.01 |
| InAs | 6.04 | -0.22 | 0.00 | 0.05 | 0.08 | 0.05 | 0.03 |
| IsSb | 6.04 | -0.20 | 0.00 | 0.04 | 0.06 | 0.05 | 0.01 |
| ZnS | 5.41 | -0.22 | 0.03 | 0.07 | 0.24 | 0.14 | 0.04 |
| ZnSe | 5.65 | -0.23 | 0.01 | 0.06 | 0.18 | 0.12 | 0.03 |
| ZnTe | 6.07 | -0.22 | 0.00 | 0.05 | 0.13 | 0.10 | 0.01 |
| CdTe | 6.41 | -0.20 | 0.00 | 0.04 | 0.15 | 0.09 | 0.04 |

2.3 Band Structure of Common Semiconductors

A calculation replicating the work of [11] was made to verify the validity of the code. Figures 2.1 through 2.14 show the results of program.

The average run time for the program was approximately 1 minute and 10 seconds. This includes calculating the eigen energies for 70, 124×124 Hamiltonian matrices or about 10 seconds per lattice point. For materials such as Si or Ge where V_A values are 0 the calculation reduces to about 1 second per lattice point. For both cases 98% of these times were spent in the eigen library calculating energies.

2.4 Finding Pseudopotentials

Ab initio techniques to find band structures can be used, but this can be both time and memory intensive. It is sometimes desirable to calculate band structure inside of a simulation for certain applications. Examples of this include studying hetero-structures with different doping gradients [13], Strained Lattices [26] or studying the effects of surface roughness [22] in a device.

EPM is a powerful method for calculating band structure and studying the effects, and there

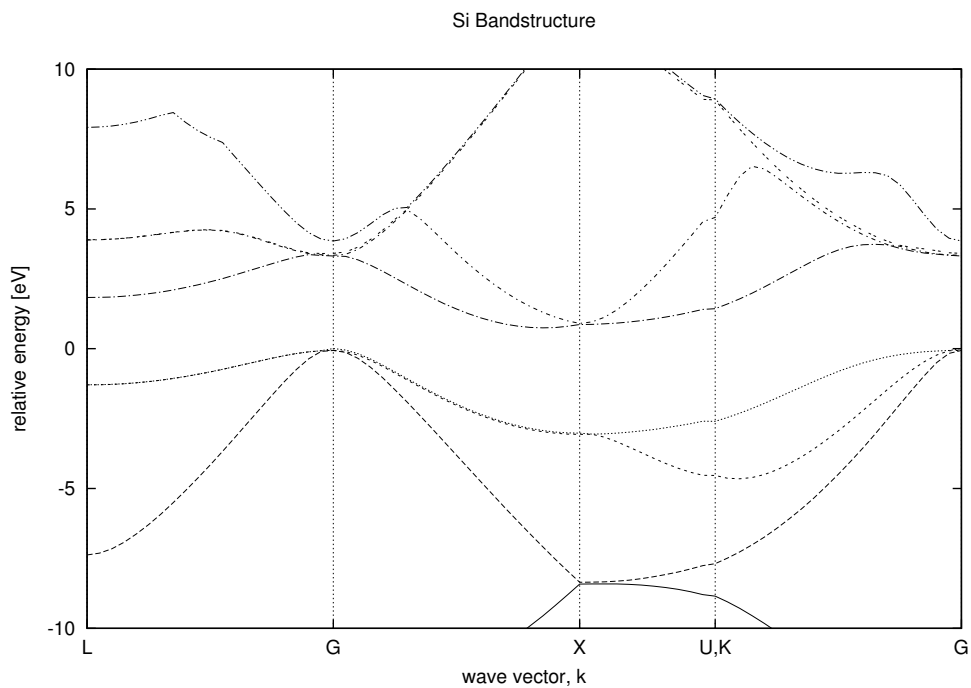


Figure 2.1: Si band structure with form factors from [11]

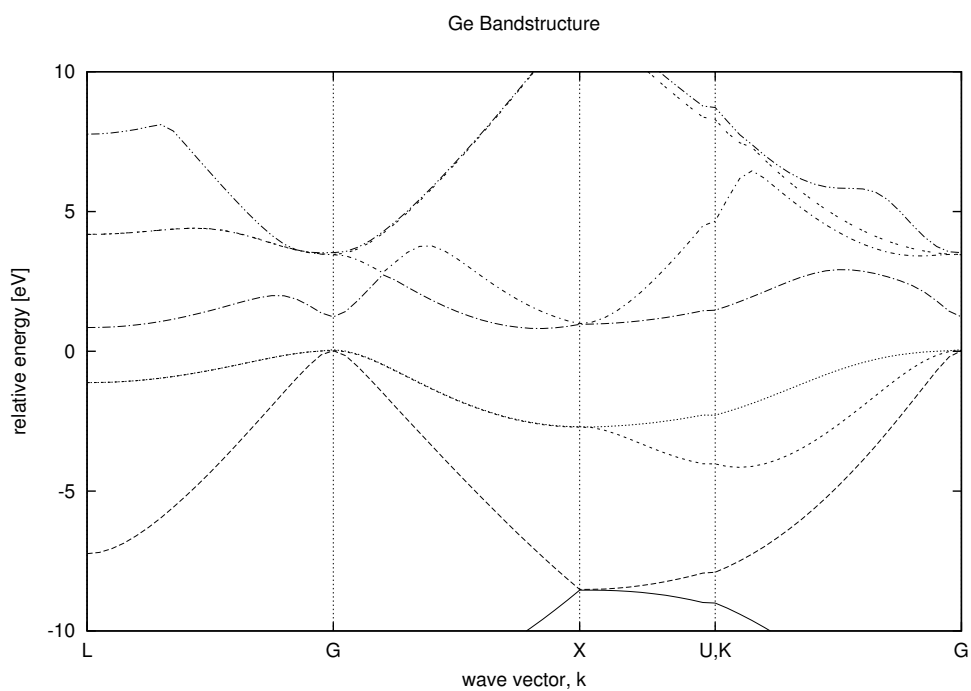


Figure 2.2: Ge band structure with form factors from [11]

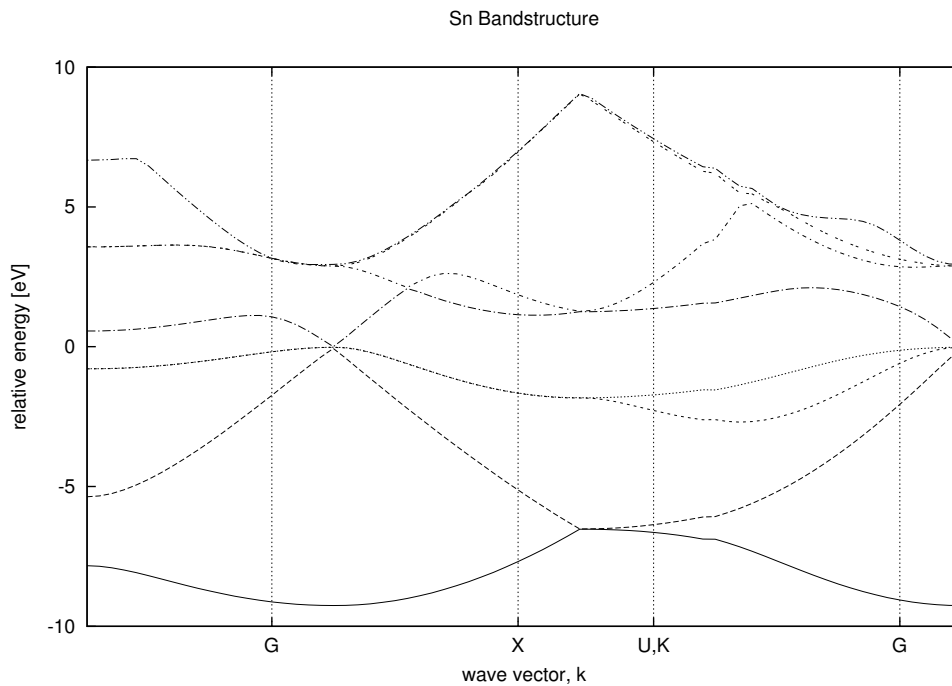


Figure 2.3: Sn band structure with form factors from [11]

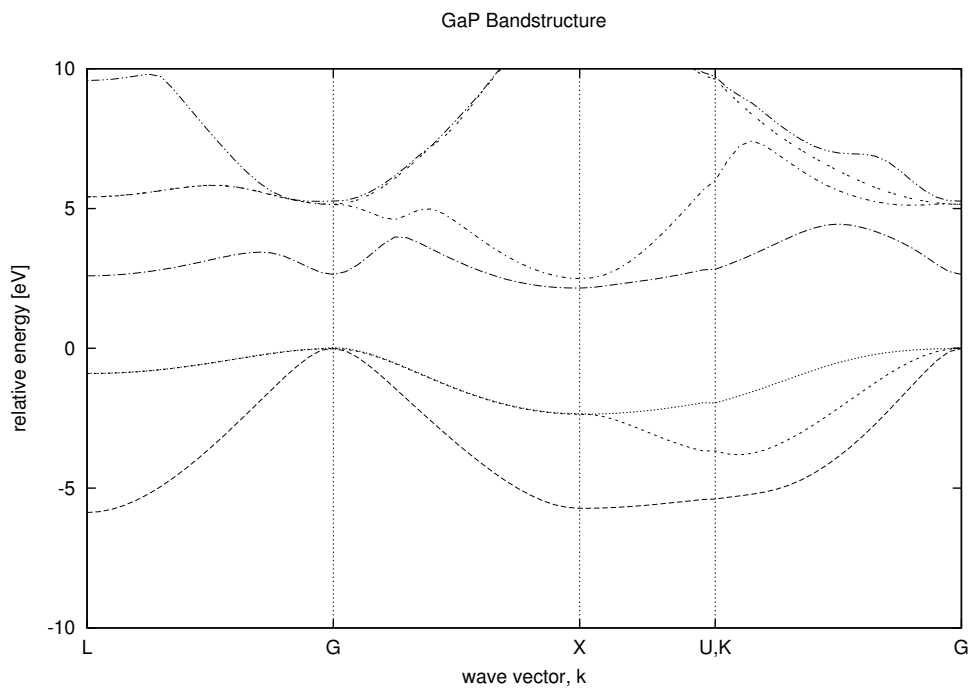


Figure 2.4: GaP band structure with form factors from [11]

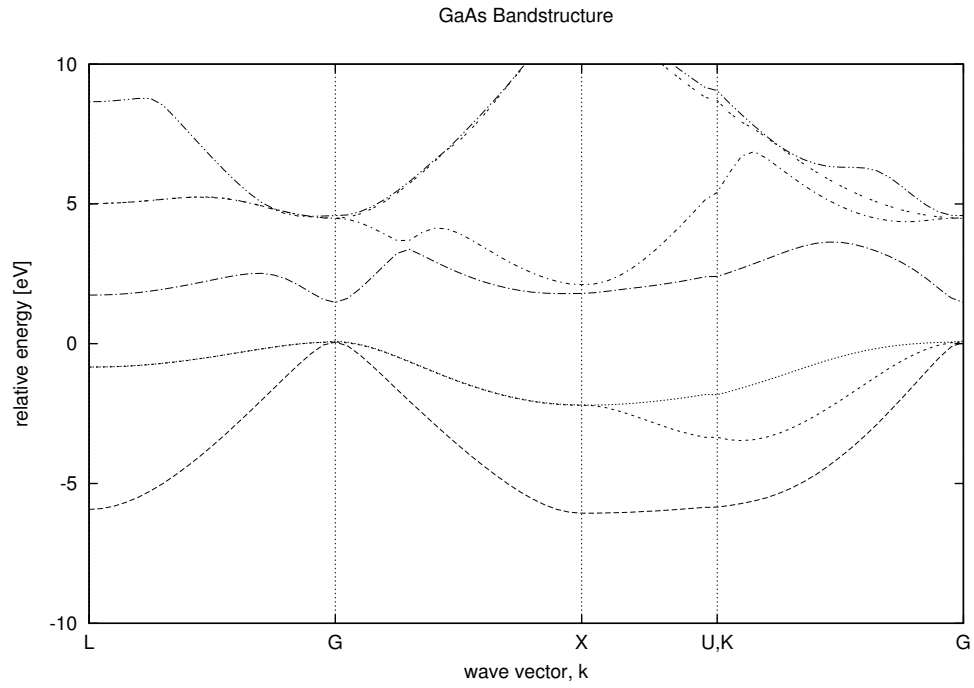


Figure 2.5: GaAs band structure with form factors from [11]

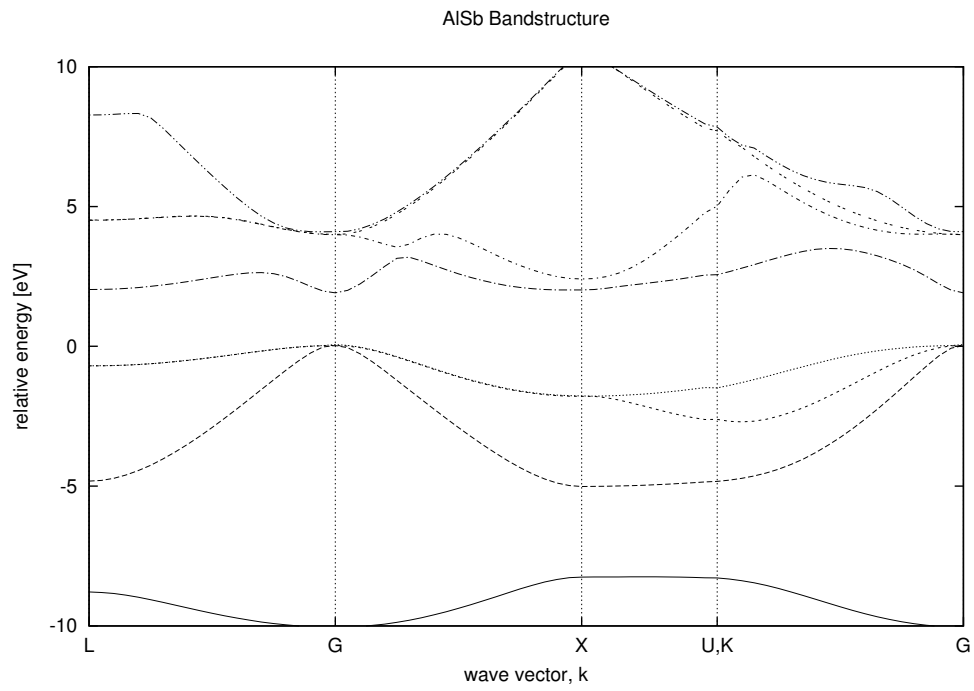


Figure 2.6: AlSb band structure with form factors from [11]

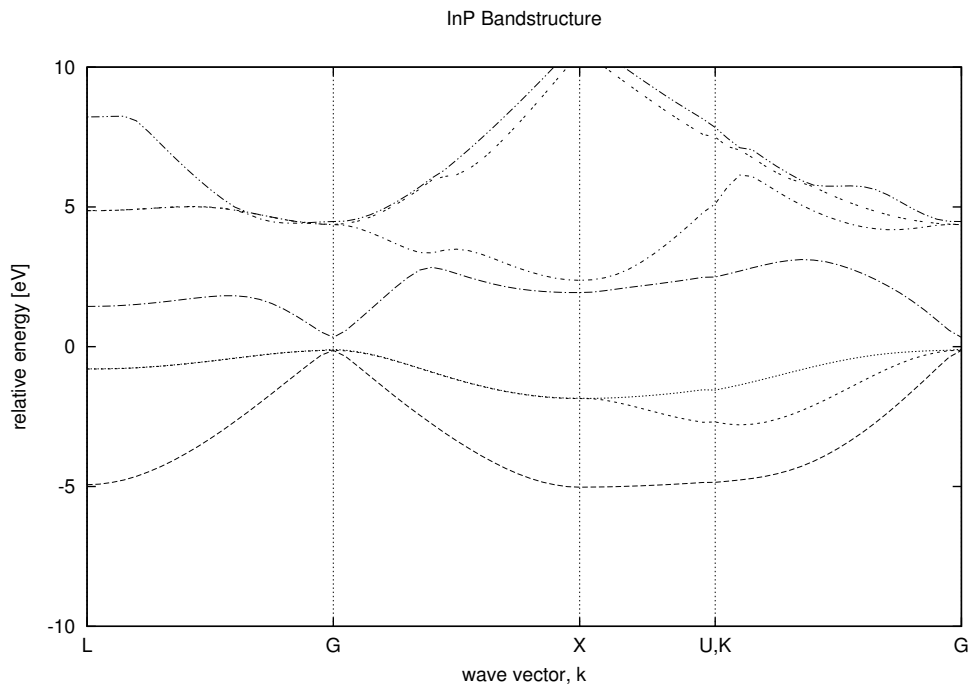


Figure 2.7: InP band structure with form factors from [11]

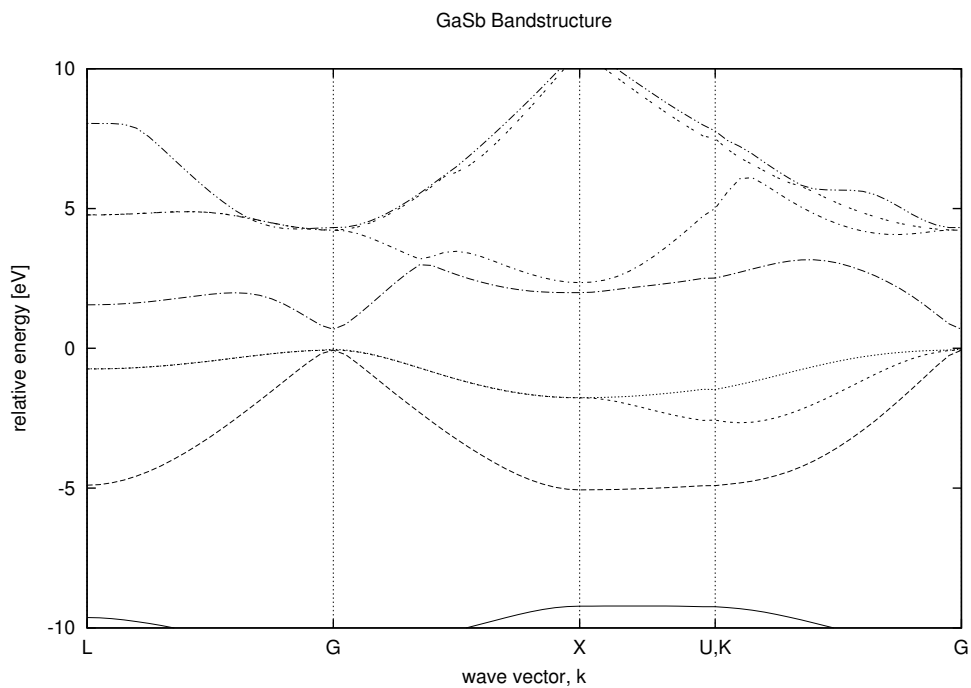


Figure 2.8: GaSb band structure with form factors from [11]

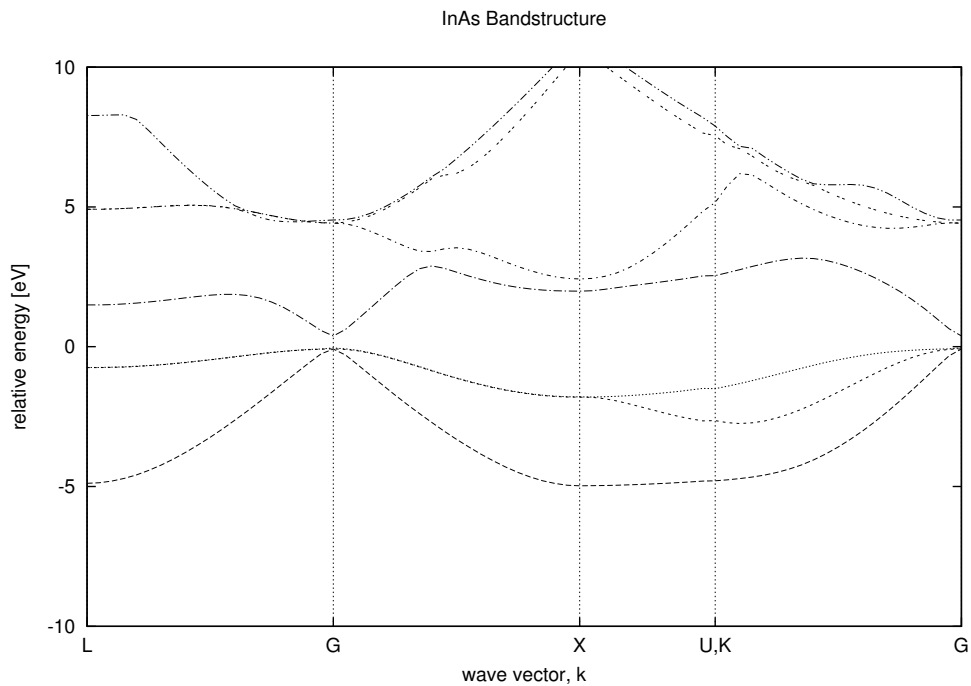


Figure 2.9: InAs band structure with form factors from [11]

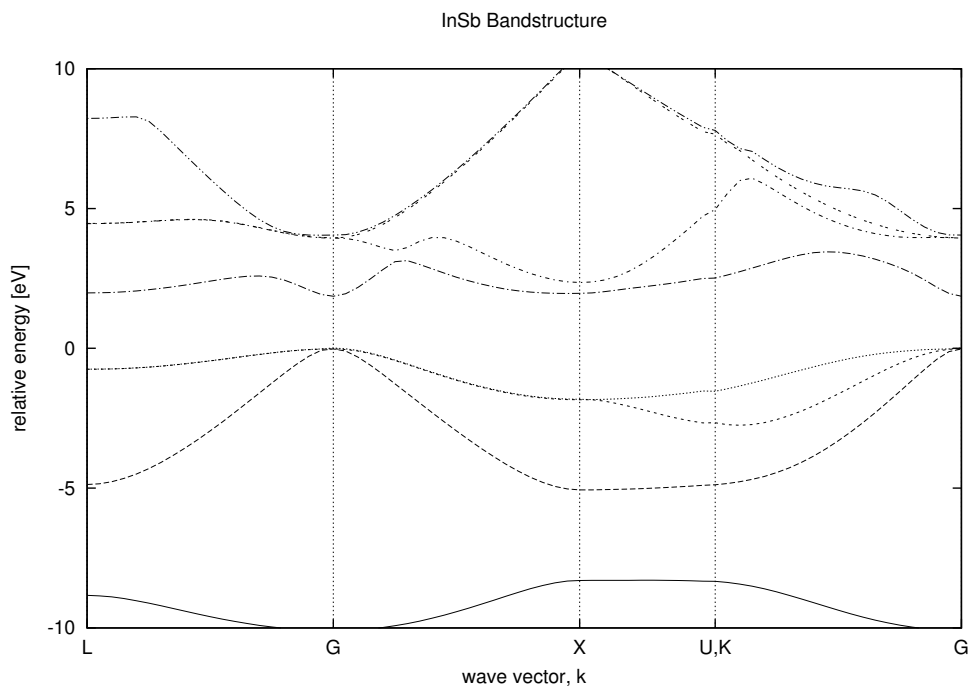


Figure 2.10: InSb band structure with form factors from [11]

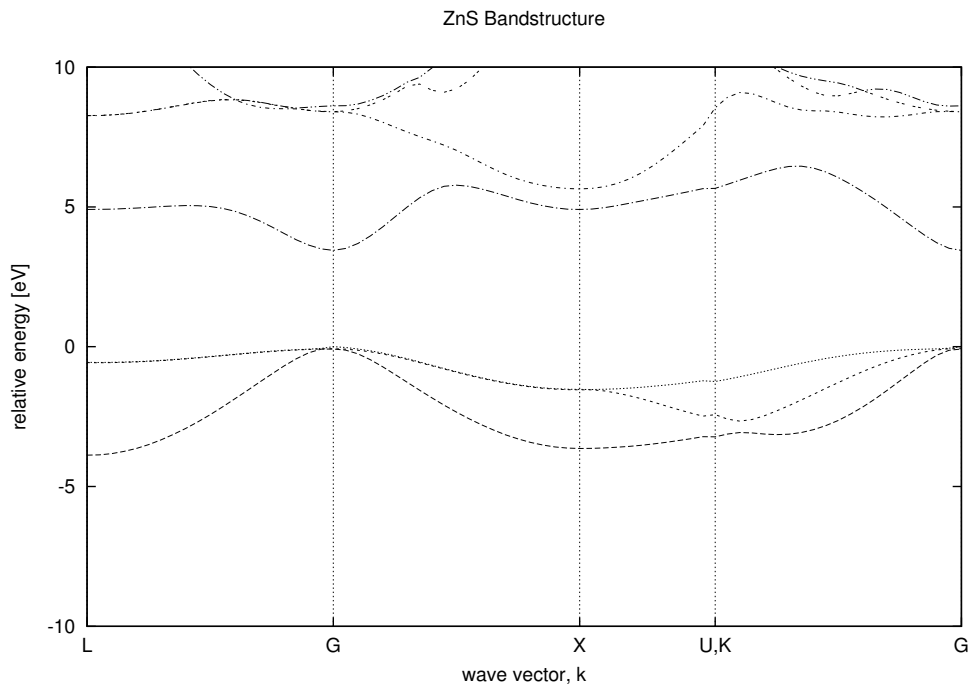


Figure 2.11: ZnS band structure with form factors from [11]

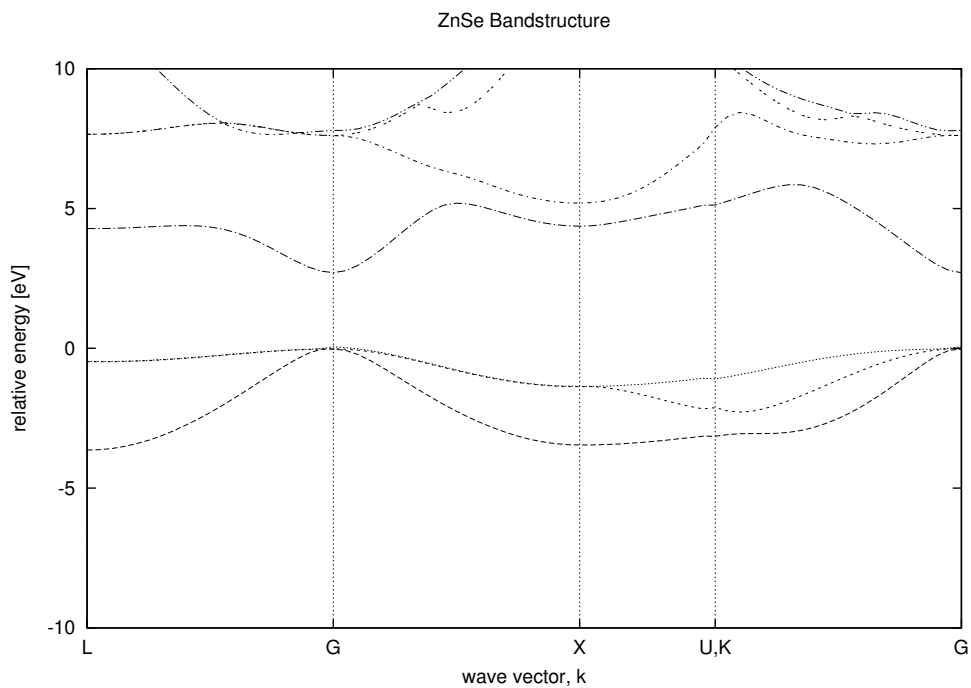


Figure 2.12: ZnSe band structure with form factors from [11]

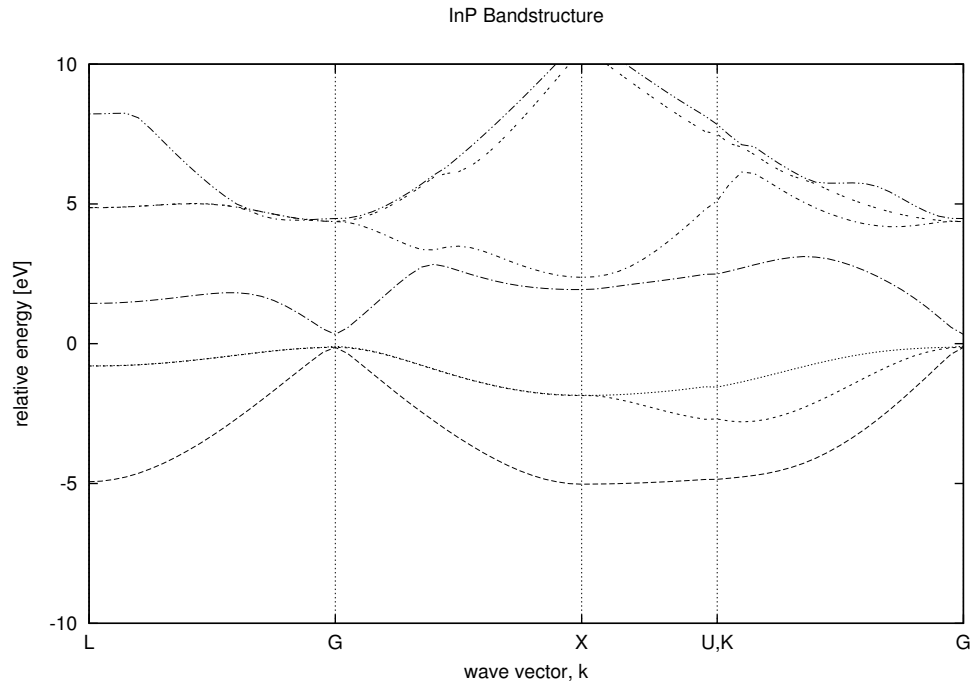


Figure 2.13: ZeTe band structure with form factors from [11]

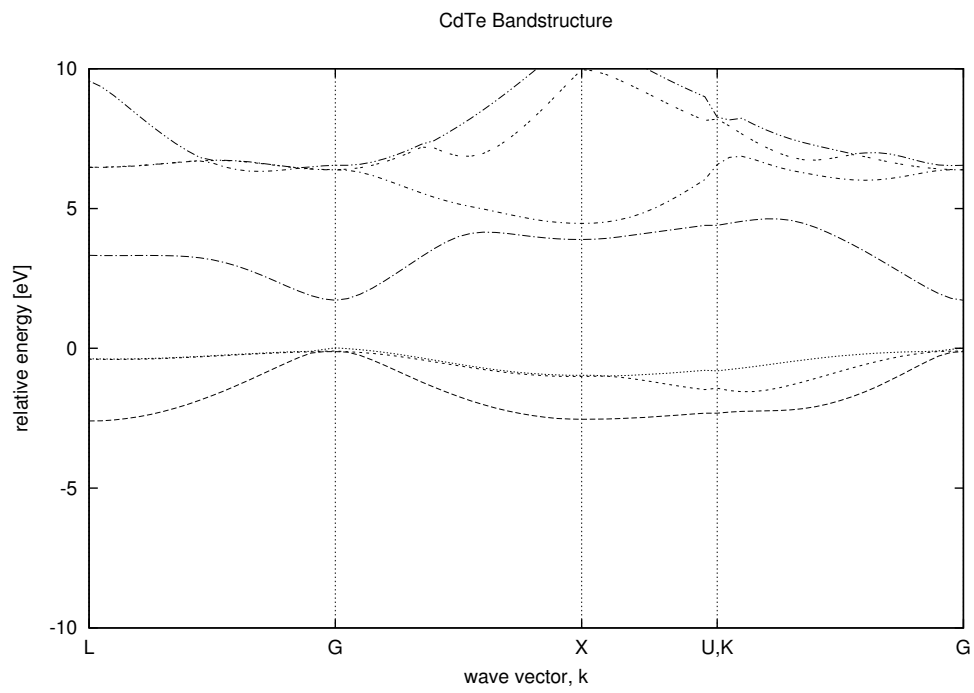


Figure 2.14: CdTe band structure with form factors from [11]

are several modern approaches to finding form factors for different applications. First-principles calculations such as LCAO can be used to find pseudopotentials. Curve fitting and Genetic algorithms can be employed to find fine grain values of band structure where data have already be acquired [34].

3. Applications

Utilizing exciting new materials such as graphene and device structures such as Silicon On Insulator (SOI) necessitates being able to predict their operation as actual devices. Ab initio approaches give insight into engineering effective geometries, but they are limited to structures in the range of thousands of atoms[20]. For any kind of large scale integration these methods fall short. EPM offers a solution for devices $\gtrsim 10^5$ atoms. There are many techniques for finding pseudopotentials that will work for different systems. Most of these methods stretch the definition of an “empirical” method. Ab initio calculations can be used to find pseudopotentials. Another procedure that will be shown below is to make a simple hybrid representation of the atomic structure in the system. Finally, stochastic methods for finding pseudopotentials have become increasingly popular. Indeed this is no longer empirical, but shows the versatility of EPM for modeling modern materials. Remarkably, pseudopotentials for armchair nanoribbons of graphene have been used to calculate band structure[31] and simulate the properties of devices.

There are situations where it becomes desirable to do band calculations inside device simulations where the band structure can change as a result of the operation of the device. This is a good application for modeling using first principles to discover pseudopotentials that could work for using EPM in the actual device.

Once band structure is known (either by ab initio or EPM) it can be mapped into effective mass and/or mobility to lessen the computational burden in actual device simulation. Work has been carried out to calculate mobility in strained materials by finding the dilation deformation potentials from unstrained materials, and then applying the strained band structure[23] to recalculate the mobility. Another method is to use Full Band Monte Carlo (FBMC) to calculate the mobility for specific common geometries[45].

3.1 Alloy Materials

First principles techniques are able to make calculations based on specific atom locations. This is of great use in studying boundary deformations. For some alloy materials there is a known concentration, and there may be a known strain. For example SiGe with highly controlled concentrations can be epitaxially grown through the use of ultrahigh-vacuum chemical vapor deposition[33]. There may even be a gradient concentration in the material. Because these materials are quasi-homogeneous virtual crystal approximation (VCA) allows the properties of two atoms to be used to make a hybrid atom[26]. For this method the strained lattice and the form factors are a function of the concentration percentage. The strained lattice can be represented as:

$$a'(x) = a_1(1 - x) + a_2x \quad (3.1)$$

Similarly the form factors can be calculated as:

$$V'(x) = V_1(1 - x) + V_2x \quad (3.2)$$

Table 3.1: Form factors of SiGe Alloy for different concentrations at 300K

| x | $a(\text{\AA})$ | V_{3S} | V_{8S} | V_{11S} | V_{3A} | V_{4A} | V_{11A} |
|------|-----------------|----------|----------|-----------|----------|----------|-----------|
| 0.00 | 5.4300 | -0.210 | 0.0400 | 0.080 | 0 | 0 | 0 |
| 0.25 | 5.4625 | -0.215 | 0.0325 | 0.075 | 0 | 0 | 0 |
| 0.50 | 5.4950 | -0.220 | 0.0250 | 0.070 | 0 | 0 | 0 |
| 0.75 | 5.5275 | -0.225 | 0.0175 | 0.065 | 0 | 0 | 0 |
| 1.00 | 5.5600 | -0.230 | 0.0100 | 0.060 | 0 | 0 | 0 |

Table 3.1 shows the parameters of SiGe alloy at differing concentrations, and figure 3.1 shows progression of how the band structure changes. The method for calculating the band structure is the same as above. It can be seen that the top band in figure 3.1(a) starts to pull down in 3.1(b), and by 3.1(c) at a concentration of $x = 50\%$ that same band is below the normal conduction band of Silicon. At $x = 75\%$ the alloy becomes Germanium-like as the direct band gap begins to takeover.

3.2 Genetic Algorithms

Genetic algorithms have become highly utilized in many aspects of semiconductor devices. They have been used to find device parameters[19], in band structure engineering[30], in direct band gap discovery[14], in reconstruction of Scanning Tunneling Microscope (STM) imagery[10] and even in optimization of manufacturing devices[50]. They have been used to because of their ability to hone into special systems by evolving from similar parent states. A detailed overview of genetic algorithms is given in [12]. Here is the abbreviated description of a genetic algorithm:

- (1) **Start.** An initial population is made. This can be either a random population or a population that already has desired traits.
- (2) **Breeding.** Breeding takes place in three steps:
 - (a) **Selection.** Parents are selected at random and weighted by their fitness and Copies.
 - (b) **Crossover.** Children exchange chromosomes.
 - (c) **Mutation.** Each chromosome has the chance to mutate by some probability.
- (3) **Repeat.** Breed until a desired trait is optimized to the selected quantity or by a predetermined number of generations.

There are many variations on this system. One of its main advantages is that many generations can be done in parallel.

Recently, genetic algorithms applied to EPM has been used to calculate the band structure for 4H-SiC [34].

3.3 Future Work

Future work will be focused on applying the band structures to actual device simulation. A framework for this purpose needs to be developed. Spin-orbit coupling is necessary for effectively simulating holes in many materials such a germanium and is an easy addition to the algorithm.

A density of states calculation is also necessary. Using a genetic algorithm find different devices' properties and simulate operation is the end goal.

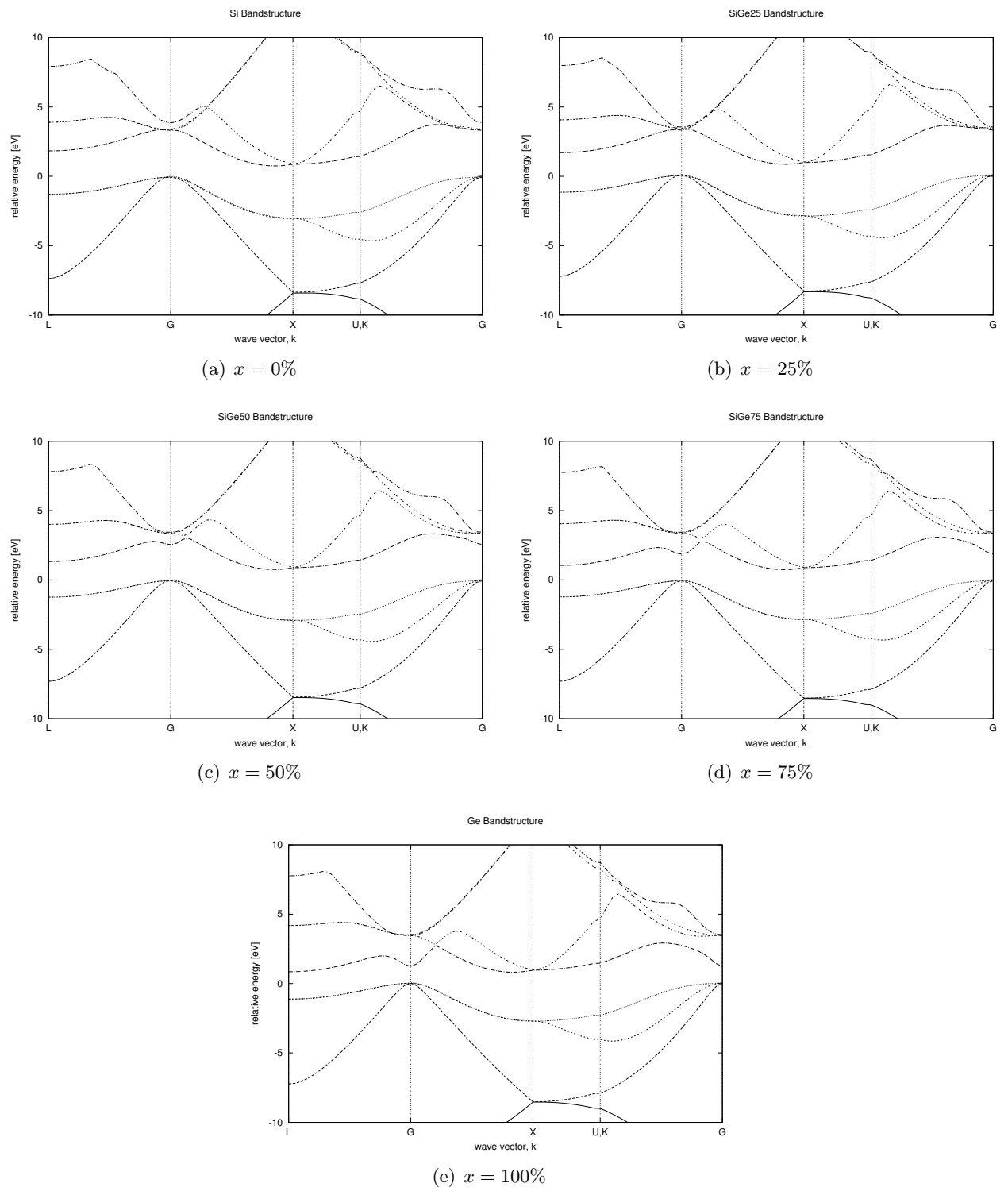


Figure 3.1: The Band Structure for Different Concentrations of Silicon-Germanium Alloy

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A. Acronyms

| | | |
|-------------|---|----|
| BZ | Brillouin Zone | 6 |
| DFT | Density Functional Theory | 1 |
| EPM | Empirical Pseudopotential Method | |
| FBMC | Full Band Monte Carlo | 17 |
| LCAO | Linear Combination of Atomic Orbitals | 1 |
| OPW | Orthogonalized Plane Wave | 5 |
| SOI | Silicon On Insulator | 17 |
| STM | Scanning Tunneling Microscope | 19 |
| TISE | Time Independent Schrodinger Equation | 6 |
| VCA | virtual crystal approximation | 18 |

B. Code Listing and Examples

It is necessary to have the Eigen Library[24] to compile and run the simulator. To compile (using the gnu compiler) and run a simulation type (from a UNIX shell):

```
1 g++ -o epm epm.cpp
  ./epm < Si.epm > Si.dat
```

The Si.epm file is a parameter file used to deliver the lattice constant, form factors and the lattice traversal info to the program. It is a very roughly parsed into the simulator.

resources/Si.epm

```
LC 5.431e-10 ; lattice constant
V 3 -0.21 0 ; Vs3 Va3
3 V 8 0.04 0
V 11 0.08 0
L 20 G 20 X 10 U 0 K 20 G ; crystal points to traverse
```

“LC” is a keyword to tell the program that the lattice constant follows after some amount of white space. “V” tells it that a form factor follows. If L, G, X, U, K or G starts a line, the parser will build the k vector and will calculate the number of points specified inside the Brillouin zone. If 0 is used, the program will still calculate one point from the reciprocal lattice.

B.1 EPM Band Structure in C++

resources/epm.cpp

```
#include <stdio.h>
#include <math.h>
#include <iostream>
#include "Eigen/Dense"
```



```

double Vs[20];
double Va[20];

45 // get parameters: lattice constant, pseudopotentials and lattice traversal
Nn = 0;
while(cin.getline(line,256)) {
    tok = strtok(line,"_");
50    if(!tok) break;

    // get lattice constant
    if(!strcmp(tok,"LC")) {
        lc = atof(strtok(NULL,"_"));
55        C = hbar*hbar*2*pi*pi/(lc*lc*m0*q);
    }

    // get pseudopotential values
    if(!strcmp(tok,"V") && ppc<20) {
60        pp[ppc] = atof(strtok(NULL,"_"));
        Vs[ppc] = atof(strtok(NULL,"_"));
        Va[ppc++] = atof(strtok(NULL,"_"));
    }

65 // get and generate k matrix
    if(!strcmp(tok,"L")) { k[0][0]= .5; k[0][1]= .5; k[0][2]= .5; Nn=1; }
    if(!strcmp(tok,"G")) { k[0][0]= 0; k[0][1]= 0; k[0][2]= 0; Nn=1; }
    if(!strcmp(tok,"X")) { k[0][0]= 1; k[0][1]= 0; k[0][2]= 0; Nn=1; }
    if(!strcmp(tok,"W")) { k[0][0]= 1; k[0][1]= .5; k[0][2]= 0; Nn=1; }
70    if(!strcmp(tok,"K")) { k[0][0]=.75; k[0][1]=.75; k[0][2]= 0; Nn=1; }
    if(!strcmp(tok,"U")) { k[0][0]= 1; k[0][1]=.25; k[0][2]=.25; Nn=1; }
    if(Nn) {
        Nn=0;
        tok = strtok(NULL,"_");
75        while(isdigit(*tok)) {
            h = atoi(tok);
            tok = strtok(NULL,"_");
            if(h==0) h=1;
            if(!strcmp(tok,"L")) { l[0]= (.5-k[Nn][0])/h; l[1]= (.5-k[Nn][1])/h; l[2]= (.5-
                k[Nn][2])/h; }

```

```

80         if(!strcmp(tok,"G")) { l[0]= (0-k[Nn][0])/h; l[1]= (0-k[Nn][1])/h; l[2]= (0-
            k[Nn][2])/h; }
        if(!strcmp(tok,"X")) { l[0]= (1-k[Nn][0])/h; l[1]= (0-k[Nn][1])/h; l[2]= (0-
            k[Nn][2])/h; }
        if(!strcmp(tok,"W")) { l[0]= (1-k[Nn][0])/h; l[1]= (.5-k[Nn][1])/h; l[2]= (0-
            k[Nn][2])/h; }
        if(!strcmp(tok,"K")) { l[0]= (.75-k[Nn][0])/h; l[1]= (.75-k[Nn][1])/h; l[2]= (0-
            k[Nn][2])/h; }
        if(!strcmp(tok,"U")) { l[0]= (1-k[Nn][0])/h; l[1]= (.25-k[Nn][1])/h; l[2]= (.25-
            k[Nn][2])/h; }
85         if(-1e-15<l[0] && l[0]<1e-15) l[0] = 0;
        if(-1e-15<l[1] && l[1]<1e-15) l[1] = 0;
        if(-1e-15<l[2] && l[2]<1e-15) l[2] = 0;
        while(h-- && (Nn<124)) {
            Nn++;
90         k[Nn][0] = k[Nn-1][0] + l[0];
            k[Nn][1] = k[Nn-1][1] + l[1];
            k[Nn][2] = k[Nn-1][2] + l[2];
            if(-1e-15<k[Nn][0] && k[Nn][0]<1e-15) k[Nn][0] = 0;
            if(-1e-15<k[Nn][1] && k[Nn][1]<1e-15) k[Nn][1] = 0;
95         if(-1e-15<k[Nn][2] && k[Nn][2]<1e-15) k[Nn][2] = 0;
        }
        tok = strtok(NULL," ");
    }
    Nn++;
100 }
}

// verify pseudopotentials
//f=ppc; while(f--) cout << pp[f] << " " << Vs[f] << " " << Va[f] << endl;
105 // verify k vector generation
// for(h=0; h<Nn; h++) printf("%i %g %g %g\n", h, k[h][0], k[h][1], k[h][2]);
// cout << endl;

// build a look up table for building K vector
110 // caution! this section must be modified if nN is modified
// needs to be updated for variable nN
f=-5;

```

```

g=0;
h=1;
115 p=&K[0][0];
while(1) {
    *p++ = -f+g+h;
    *p++ = f-g+h;
    *p++ = f+g-h;
120
    if(f==5 && g==0 && h==-1) break;
    if(++h>2) {
        h=-2;
        if(++g>2) {
125             g=-2;
             f++;
        }
    }
}
130 // verify K vector generation
//printf("\n"); for(h=0; h<249; h++) printf("%i %g %g %g\n", h-124, K[h][0], K[h][1], K[h
][2]);

// generate Hamiltonian with out diagonals
for(f=0; f<nN ; f++) for(g=0; g<f; g++) {
135     // calculate pseudopotential
    h = f+124-g;

    // search pseudopotential table
    V = 0;
140    d = ppc;
    e = (int)dot(&K[h][0],&K[h][0]);
    while(d--) if(e == pp[d]) {
//        V = Vs[d]*13.6059;
        V.real(Vs[d]*13.6059);
145        V.imag(Va[d]*13.6059);
        break;
    }
//    V = V*cos(2*pi*dot(&K[h][0],&T[0]));
    V.real(real(V)*cos(2*pi*dot(&K[h][0],&T[0])));

```

```

150     V.imag(imag(V)*sin(2*pi*dot(&K[h][0],&T[0])));
        HH(f,g) = V;
    }

    // create diagonals for each k space and find energies!
155    for(f=0; f<Nn; f++) {
        // calculate diagonals
        for(g=0; g<nN; g++) {
            h = g + 62;
            l[0] = k[f][0] + K[h][0];
            160    l[1] = k[f][1] + K[h][1];
            l[2] = k[f][2] + K[h][2];
            //    H[g][g] = C*dot(l[0],l[0]);
            HH(g,g) = C*dot(l[0],l[0]);
        }
165    SelfAdjointEigenSolver<Matrix124cd> eigensolver(HH);
        cout << eigensolver.eigenvalues().transpose() << endl;
    }

    // varify full Hamiltonian
170    //for(f=0; f<nN; f++) for(g=0; g<f+1; g++) cout << " " << f << " " << g << " " << HH.
        block(f,g,1,1) << " " << endl;
}

```

B.2 Gnuplot Example

[38] was used to generate the plots in this paper. Which can be done by:

```
gnuplot Si.gp
```

resources/Si.gp

```

set key off
set title "Si_Bandstructure\n"
set xlabel "wave_vector,k"
4 set ylabel "relative_energy[eV]"

```

```

unset x2tics
set grid x
set yr [-10:10]
set xtics ("L" 0 , "G" 20, "X" 40, "U,K" 51, "G" 71)
9 plot "Si.dat" using ($1-10.54) with lines
  replot "Si.dat" using ($2-10.54) with lines
  replot "Si.dat" using ($3-10.54) with lines
  replot "Si.dat" using ($4-10.54) with lines
  replot "Si.dat" using ($5-10.54) with lines
14 replot "Si.dat" using ($6-10.54) with lines
  replot "Si.dat" using ($7-10.54) with lines
  replot "Si.dat" using ($8-10.54) with lines
  pause -1
  set term postscript eps enhanced
19 set output "Si.eps"

plot "Si.dat" using ($1-10.54) with lines, "Si.dat" using ($2-10.54) with lines, "Si.dat"
  using ($3-10.54) with lines, "Si.dat" using ($4-10.54) with lines, "Si.dat" using ($5
    -10.54) with lines, "Si.dat" using ($6-10.54) with lines, "Si.dat" using ($7-10.54) with
      lines, "Si.dat" using ($8-10.54) with lines

```
